

# AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s):

Docket No.

IIZ.003D2

Serial No.

09/920,713

Filing Date

August 3, 2001

Examiner

F. Toledo

Group Art Unit

2823

Invention: SEMICONDUCTOR APPARATUS AND METHOD FOR FABRICATING THE SAME (To be Amended)

## TO THE ASSISTANT COMMISSIONER FOR PATENTS:

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

### CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	7 -	20 =	0 x	\$18.00	\$0.00
INDEP. CLAIMS	2 -	3 =	0 x	\$84.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

- ☒ No additional fee is required for amendment.
- ☐ Please charge Deposit Account No. \_\_\_\_\_ in the amount of \_\_\_\_\_  
A duplicate copy of this sheet is enclosed.
- ☐ A check in the amount of \_\_\_\_\_ to cover the filing fee is enclosed.
- ☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 50-0238  
A duplicate copy of this sheet is enclosed.
- ☒ Any additional filing fees required under 37 C.F.R. 1.16.
- ☒ Any patent application processing fees under 37 CFR 1.17.

  
Signature

Dated: February 3, 2003

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I certify that this document and fee are being deposited on \_\_\_\_\_ with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

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2-12-03  
IIZ.003D2  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Takashi Ohsumi

Group Art Unit: 2823

Serial No.: 09/920,713

Examiner: F. Toledo

Filed: August 3, 2001

For: SEMICONDUCTOR APPARATUS AND METHOD FOR FABRICATING  
THE SAME (To Be Amended)

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AMENDMENT

Honorable Assistant Commissioner for Patents  
Washington, D.C. 20231

Date: February 3, 2003

Sir:

In response to the Office Action dated November 6, 2002, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

In the Title:

Please amend the title to read --A METHOD FOR FABRICATING A  
SEMICONDUCTOR APPARATUS INCLUDING A SEALING MEMBER WITH  
REDUCED THERMAL STRESS--.

In the Abstract:

Please cancel the Abstract and replace with the Abstract attached herewith.